

DESIGNATION OF INVENTORS

FIRST INVENTOR:

NAME: **GÜNTER SCHWAB**
RESIDENCE: **EMMERTING, GERMANY**
CITIZENSHIP: **GERMAN**
P.O. ADDRESS: **LINDENWEG 2A
D-84547 EMMERTING, GERMANY**

SECOND INVENTOR:

NAME: **HELMUT FRANKE**
RESIDENCE: **BURGHAUSEN, GERMANY**
CITIZENSHIP: **GERMAN**
P.O. ADDRESS: **LION-FEUCHTWANGER-WEG 8
D-84489 BURGHAUSEN, GERMANY**

THIRD INVENTOR:

NAME: **MANFRED SCHÖFBERGER**
RESIDENCE: **REUT, GERMANY**
CITIZENSHIP: **GERMAN**
P.O. ADDRESS: **SIMBACHER STRASSE 9
D-84367 REUT, GERMANY**

Title: **PROCESS FOR PRODUCING A SEMICONDUCTOR WAFER**

Priority: **GERMAN PATENT APPLICATION #100 02 354.1**

FILED: **JANUARY 20, 2000**